Special Union for the International Patent Classification (IPC Union)
Committee of Experts

Fifty-Second Session
Geneva, February 19 and 20, 2020

DRAFT AGENDA

prepared by the Secretariat

1. Opening of the session
2. Election of a Chair and two Vice-Chairs
3. Adoption of the agenda
   See present document.
   See project CE 529.
5. Report on the progress of the IPC revision program
   See project CE 462.
6. Review of pilot project F 082 for IPC e-forum discussions
   See project CE 529.
7. Report on the progress of the CPC and FI revision programs
   Reports by the EPO and the USPTO on the CPC and by the JPO on the FI.
8. Consideration of the need to create a new class covering semiconductor technology
   See project CE 481.
9. Amendments to the Guide to the IPC and other basic IPC documents
   See projects CE 454, CE 455 and CE 512.
10. Handover of the Working Lists management from the EPO to WIPO  
    Presentation by the International Bureau.

11. Report on IPC-related IT systems  
    Presentation by the International Bureau.

12. Experience from offices on computer-assisted (e.g., AI-based) classification  
    Presentations by offices.

13. Divergences in IPC allocations  
    See project CE 529.

14. Framework of technical competencies for patent classification  
    See project CE 529.

15. Closing of the Session

   The opening meeting will start on Wednesday, February 19, 2020, at 10 a.m., at the  
   Headquarters of WIPO, 34 chemin des Colombettes, Geneva.

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